



PATENT  
81877.012

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Seiyo NAKASHIMA

Serial No: 09/816,643

Filed: march 23, 2001

For: SUBSTRATE PROCESSING  
APPARATUS AND SUBSTRATE  
PROCESSING METHOD

Art Unit: 1763

Examiner: Kackar, Ram N.

I hereby certify that this correspondence  
is being deposited with the United States  
Postal Service with sufficient postage as  
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to:

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450, on  
October 10, 2003

Date of Deposit

Ying Chen, Reg. No. 50,193

Name

Signature *Ying Chen* October 10, 2003

Signature

Date

**PETITION FOR EXTENSION OF TIME**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

In accordance with 37 C.F.R. 1.136, Applicant respectfully petitions the  
Commissioner for a three-month extension of time extending to October 10, 2003,  
the period for response to the Office Action dated April 10, 2003. A check for  
\$950.00 is enclosed. The responsive paper(s) are attached.

Please charge any insufficiency or credit any overpayment to Deposit Account  
No. 50-1314. A copy of this petition is enclosed.

Respectfully submitted,

HOGAN & HARTSON L.L.P.

Date: October 10, 2003

By: *Ying Chen*  
Ying Chen  
Registration No. 50,193  
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